CLEANING OF BONDED SILICON ELECTRODES

ABSTRACT

Method of cleaning elastomer bonded electrode assembly having a silicon member (20) with a plasma-exposed silicon surface, a backing member (80), and an elastomer bonding material (90) between the silicon surface and the backing member. The method includes contacting surfaces of the components with a cleaning solution (10), while avoiding damage of other surfaces or areas of the components by the cleaning solution (10).

Figure 1